

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	576349	mill\$3 or micromachin\$3	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L2	25583	(mill\$3 or micromachin\$3) and deposit and ion	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L3	10886	((mill\$3 or micromachin\$3) and deposit and ion) and vacuum	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L4	4252	((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L5	2268	(((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L6	830	((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L7	737	((((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L8	737	(((((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L9	641	((((((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4) and ((deposit\$4 or remov\$4) near6 (target or sample or wafer or substrate))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L10	172	(((((((((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4) and ((deposit\$4 or remov\$4) near6 (target or sample or wafer or substrate)))) and (focus\$4 near4 beam)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L11	1676	(focus\$3 adj ion adj beam) and deposit\$4	USPAT	OR	OFF	2004/11/09 14:02
L12	615	((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)	USPAT	OR	OFF	2004/11/09 14:02

L13	204	(((((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)) and lens\$2	USPAT	OR	OFF	2004/11/09 14:02
L14	160	(((((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)) and lens\$2) and imag\$\$	USPAT	OR	OFF	2004/11/09 14:02
L15	1001	((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)	US-PGPUB; USPAT	OR	OFF	2004/11/09 14:02
L16	2641	(focus\$3 adj ion adj beam) and deposit\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L17	1038	((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L18	367	(((((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)) and lens\$2	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L19	46407	(mill\$3 or micromachin\$3 or etch\$3) and deposit and ion	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L20	779	((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 adj ion adj beam)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L21	2145	((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L22	351	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture)))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L23	238	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture))) and lens\$3	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L24	178	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture))) and lens\$3) and vacuum	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L25	2641	((focus\$3 adj ion adj beam) and deposit\$4)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L26	868	(((((focus\$3 adj ion adj beam) and deposit\$4)) and aperture	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L27	2571	((mill\$3 or micromachin\$3) and deposit and ion) and aperture	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02

L28	64	((mill\$3 or micromachin\$3) and deposit and ion) and aperture) and (rectang\$5 near3 aperture)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L29	140	((mill\$3 or micromachin\$3) and deposit and ion) and aperture) and ((rectang\$5 or square) near8 aperture)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L30	895	250/309	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L31	2863	250/306	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L32	1	gerlach-robert.in.	USPAT	OR	OFF	2004/11/09 14:02
L33	0	vandermast-karl.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L34	2439	250/307	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L35	1319	250/492.21	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L36	2432	250/492.1	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L37	576358	mill\$3 or micromachin\$3 or overmill\$3	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L38	25583	(mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L39	2410	((mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion) and (current near2 density)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L40	3	((mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion) and (current near2 density)) and (\$4Guass\$4 or (non adj gauss\$4))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L41	42	ion and overmill\$4	USPAT	OR	OFF	2004/11/09 14:02
L42	62	ion and overmill\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02
L43	34	(((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4) and ((deposit\$4 or remov\$4) near6 (target or sample or wafer or substrate))) and \$4Gauss\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02

L44	103	(((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4) and ((deposit\$4 or remov\$4) near6 (target or sample or wafer or substrate))) and (focus\$4 near4 beam)) and column	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L45	3	(US-5973295-\$ or US-5916424-\$ or US-5061850-\$).did.	USPAT	OR	OFF	2004/11/09 14:02
L46	6	"5262617".pn. or "5186982".pn. or "5159171".pn. or "5151377".pn. or "51106150".pn. or "5099090".pn. or "4959112".pn.	USPAT	OR	OFF	2004/11/09 14:02
L47	5	"FIB-CVD"	USPAT	OR	OFF	2004/11/09 14:02
L48	112	(((((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)) and lens\$2) and imag\$\$) and vacuum	USPAT	OR	OFF	2004/11/09 14:02
L49	65	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture))) and lens\$3) and vacuum) and imag\$3) and electrode	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L50	125	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture))) and lens\$3) and vacuum) and imag\$3	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L51	27	(((((focus\$3 adj ion adj beam) and deposit\$4) and aperture) and ("knife-edge" or knife)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L52	4	(((((mill\$3 or micromachin\$3) and deposit and ion) and aperture) and (rectang\$5 near3 aperture)) and knife	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L53	3	(((((mill\$3 or micromachin\$3) and deposit and ion) and aperture) and ((rectang\$5 or square) near8 aperture)) and (knife same aperture)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02

L54	11	(US-5973295-\$ or US-5916424-\$ or US-5061850-\$ or US-6177670-\$ or US-5952658-\$ or US-5852297-\$ or US-5583344-\$ or US-5151605-\$ or US-5120925-\$ or US-5389196-\$ or US-RE33193-\$).did.	USPAT	OR	OFF	2004/11/09 14:02
L55	1	"4698236".pn.	USPAT	OR	OFF	2004/11/09 14:02
L56	2	gerlach-robert.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L57	1	utlaut-mark.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L58	3	tesch-paul.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L59	20	young-richard.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L60	4	chandler-clive.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L61	49	van\$1der\$1mast	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L62	2	"4698236".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02
L63	3	((((mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion) and (current near2 density))) and (Guass\$4 or (non adj gauss\$4))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L64	17	((((mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion) and (current near2 density))) and ((\$4Guass\$4 or (non adj gauss\$4)) or (hollow near2 beam))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:02
L65	35	(ion and overmill\$4) and density	USPAT	OR	OFF	2004/11/09 14:02
L66	46	(ion and overmill\$4) and density	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02
L67	46	(ion and overmill\$4) and density	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02
L68	11	overmill\$4 and (current near3 density)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02

L69	117	(shap\$4 near2 beam) and (mill\$4 or overmill\$4) and (uniform near3 density)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02
L70	102	(shap\$4 near2 beam) and (mill\$3 or overmill\$4) and (uniform near3 density)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02
L71	2	"6048588".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02
L72	1	"6048588".pn. and ion	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:02
L73	576349	mill\$3 or micromachin\$3	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L74	25583	(mill\$3 or micromachin\$3) and deposit and ion	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L75	10886	((mill\$3 or micromachin\$3) and deposit and ion) and vacuum	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L76	4252	((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L77	2268	(((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L78	830	((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L79	737	((((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L80	737	(((((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L81	641	((((((((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4) and ((deposit\$4 or remov\$4) near6 (target or sample or wafer or substrate))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23

L82	172	(((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4) and ((deposit\$4 or remov\$4) near6 (target or sample or wafer or substrate))) and (focus\$4 near4 beam)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L83	1676	(focus\$3 adj ion adj beam) and deposit\$4	USPAT	OR	OFF	2004/11/09 14:23
L84	615	((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)	USPAT	OR	OFF	2004/11/09 14:23
L85	204	((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)) and lens\$2	USPAT	OR	OFF	2004/11/09 14:23
L86	160	(((((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)) and lens\$2) and imag\$4)	USPAT	OR	OFF	2004/11/09 14:23
L87	1001	((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)	US-PGPUB; USPAT	OR	OFF	2004/11/09 14:23
L88	2641	(focus\$3 adj ion adj beam) and deposit\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L89	1038	((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L90	367	((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)) and lens\$2	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L91	46407	(mill\$3 or micromachin\$3 or etch\$3) and deposit and ion	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L92	779	((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 adj ion adj beam)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L93	2145	((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L94	351	((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L95	238	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture)))) and lens\$3	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23

L96	178	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture))) and lens\$3) and vacuum	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L97	2641	((focus\$3 adj ion adj beam) and deposit\$4)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L98	868	((focus\$3 adj ion adj beam) and deposit\$4)) and aperture	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L99	2571	((mill\$3 or micromachin\$3) and deposit and ion) and aperture	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L100	64	((mill\$3 or micromachin\$3) and deposit and ion) and aperture) and (rectang\$5 near3 aperture)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L101	140	((mill\$3 or micromachin\$3) and deposit and ion) and aperture) and ((rectang\$5 or square) near8 aperture)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L102	895	250/309	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L103	2863	250/306	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L104	1	gerlach-robert.in.	USPAT	OR	OFF	2004/11/09 14:23
L105	0	vandermast-karl.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L106	2439	250/307	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L107	1319	250/492.21	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L108	2432	250/492.1	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L109	576358	mill\$3 or micromachin\$3 or overmill\$3	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L110	25583	(mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L111	2410	((mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion) and (current near2 density)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L112	3	((mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion) and (current near2 density)) and (\$4Guass\$4 or (non adj gauss\$4))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L113	42	ion and overmill\$4	USPAT	OR	OFF	2004/11/09 14:23

L114	62	ion and overmill\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23
L115	34	(((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4) and ((deposit\$4 or remov\$4) near6 (target or sample or wafer or substrate))) and \$4Gauss\$4	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L116	103	(((((mill\$3 or micromachin\$3) and deposit and ion) and vacuum) and electrode) and detect\$4) and lens\$2) and imag\$4) and deposit\$4) and ((deposit\$4 or remov\$4) near6 (target or sample or wafer or substrate))) and (focus\$4 near4 beam)) and column	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L117	3	(US-5973295-\$ or US-5916424-\$ or US-5061850-\$).did.	USPAT	OR	OFF	2004/11/09 14:23
L118	6	"5262617".pn. or "5186982".pn. or "5159171".pn. or "5151377".pn. or "51106150".pn. or "5099090".pn. or "4959112".pn.	USPAT	OR	OFF	2004/11/09 14:23
L119	5	"FIB-CVD"	USPAT	OR	OFF	2004/11/09 14:23
L120	112	(((((focus\$3 adj ion adj beam) and deposit\$4) and (micromachine or mill\$3)) and lens\$2) and imag\$4) and vacuum	USPAT	OR	OFF	2004/11/09 14:23
L121	65	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture))) and lens\$3) and vacuum) and imag\$3) and electrode	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L122	125	(((((mill\$3 or micromachin\$3 or etch\$3) and deposit and ion) and (focus\$3 near2 beam)) and (shap\$4 near3 (beam or aperture))) and lens\$3) and vacuum) and imag\$3	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L123	27	(((((focus\$3 adj ion adj beam) and deposit\$4) and aperture) and ("knife-edge" or knife)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23

L124	4	(((((mill\$3 or micromachin\$3) and deposit and ion) and aperture) and (rectang\$5 near3 aperture)) and knife	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L125	3	(((((mill\$3 or micromachin\$3) and deposit and ion) and aperture) and ((rectang\$5 or square) near8 aperture)) and (knife same aperture)	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L126	11	(US-5973295-\$ or US-5916424-\$ or US-5061850-\$ or US-6177670-\$ or US-5952658-\$ or US-5852297-\$ or US-5583344-\$ or US-5151605-\$ or US-5120925-\$ or US-5389196-\$ or US-RE33193-\$).did.	USPAT	OR	OFF	2004/11/09 14:23
L127	1	"4698236".pn.	USPAT	OR	OFF	2004/11/09 14:23
L128	2	gerlach-robert.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L129	1	utlaut-mark.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L130	3	tesch-paul.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L131	20	young-richard.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L132	4	chandler-clive.in.	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L133	49	van\$1der\$1mast	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L134	2	"4698236".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23
L135	3	(((((mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion) and (current near2 density))) and (Guass\$4 or (non adj gauss\$4))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L136	17	(((((mill\$3 or micromachin\$3 or overmill\$3) and deposit and ion) and (current near2 density))) and ((\$4Guass\$4 or (non adj gauss\$4)) or (hollow near2 beam))	US-PGPUB; USPAT	OR	ON	2004/11/09 14:23
L137	35	(ion and overmill\$4) and density	USPAT	OR	OFF	2004/11/09 14:23
L138	46	(ion and overmill\$4) and density	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23

L139	46	(ion and overmill\$4) and density	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23
L140	11	overmill\$4 and (current near3 density)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23
L141	117	(shap\$4 near2 beam) and (mill\$4 or overmill\$4) and (uniform near3 density)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23
L142	102	(shap\$4 near2 beam) and (mill\$3 or overmill\$4) and (uniform near3 density)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23
L143	2	"6048588".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23
L144	1	"6048588".pn. and ion	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:23
L145	5046	250/492.2	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:24
L146	1106	250/492.22	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:24
L147	2938	250/492.1	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:24
L148	713	219/229	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:24
L149	550	219/121.12	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:25
L150	286	204/298.36	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:25

L151	1020	216/66	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:25
L152	928	427/554	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/09 14:25